Receipt date: 12/01/2009

LMC:ejv 12/01/09 23-65037-01 13664-B

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INFORMATION DISCLOSURE STATEMENT
BY APPLICANT

	Filed Via EFS
Attorney Docket Number	23-65037-01
Application Number	10/726,744
Filing Date	December 2, 2003
First Named Inventor	Larry C. Olsen
Art Unit	1795
Examiner Name	Jeffrey Thomas Barton

U.S. PATENT DOCUMENTS

Copies of U.S. Patent documents do not need to be provided, unless requested by the Patent and Trademark Office. For patents, provide the patent number and the issue date. For published U.S. applications, provide the publication number and the publication date. For unpublished pending patent amplications rovide the application pumber and the filling date and submit a copy.

Examiner's Initials*	Cite No. (optional)	Number	Date	Name of Applicant or Patentee
		3,900,603	8/1975	Rittmayer et al.
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		JP	2003-92432	3/2003	
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		WIPO	99/54941	10/1999	

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Examiner's Initials*	Cite No. (optional)	OTHER DOCUMENTS
		Kim, et al., "Effects of a Reduction Treatment and Te Doping Properties of (Bi1-xSbx)2Te3
		Fabricated by Mechanical Alloying," 16th International Conference on Thermoelectrics, pp. 127 130 (1997).
		Yamashita, O. et al., "Bismuth telluride compounds with high thermoelectric figures of merit," Journal of Applied Physics, Vol. 93, No. 1, pp. 368-374 (January 1, 2003).

EXAMINER SIGNATURE:

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